



RECEIVED

DEC 28 2001

Technology Center 2100

LIST OF RELATED CASES

<u>Docket Number</u>	<u>Serial or Patent No.</u>	<u>Filing or Issue Date</u>	<u>Status or Patentee</u>
PN 214295US2RD*	09/960,337	09/24/01	PENDING
PN 214329US2RD	09/960,745	09/24/01	PENDING

gjm/sdj 12/10/01

*Present application; listed for information.

GJM/sdj

I:\em\EMRe\213s214s\214295US LIST.wpd



LIST OF RELATED CASES

	<u>Docket Number</u>	<u>Serial or Patent Number</u>	<u>Filing or Issue Date</u>	<u>Inventor/Applicant</u>
PN	214295US2 RD*	09/960,337	09/24/01	FUJIHARA et al.
PN	246308US2 RD	10/729,982	12/09/03	FUJIHARA et al.

RECEIVED

MAR 10 2004

12/10/04

Technology Center 2100

*Present Application; listed for information

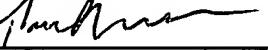
EHK/gyy

I:\EM\EMREL\213s-214s\214295US LIST.doc



Form PTO 1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO. 214295US2RD		SERIAL NO. 09/960,337		
LIST OF REFERENCES CITED BY APPLICANT			APPLICANT Mutsumi FUJIHARA, et al.				
			FILING DATE September 24, 2001		GROUP 2171		
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
PNB	AA	5,881,380	03/09/99	S. MOCHIZUKI, et al.			
PNB	AB	6,128,610	10/03/2000	J. SRINIVASAN, et al.			RECEIVED
PNB	AC	5,758,347	05/26/98	S. W. LO, et al.			JUN 09 2003
	AD						
	AE						Technology Center 2100
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES	NO	
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW						
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner <i>Paul H. Henn</i>				Date Considered 12/10/04			

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 214295US2RD		SERIAL NO. NEW APPLICATION	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Mutsumi FUJIHARA, et al.			
		FILING DATE HEREWITH		GROUP			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES	NO	
PNB	AO	JP 6-309295	11/04/94	JAPAN (w/English Abstract)		x	
PNB	AP	JP 6-149634	05/31/94	JAPAN (w/English Abstract)		x	
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Mutsumi FUJIHARA, et al., "SIMULATION THROUGH EXPLICIT STATE DESCRIPTION AND ITS APPLICATION TO SEMICONDUCTOR FAB OPERATION", Proceedings of the 1992 Winter Simulation Conference, 1992, pp 899-907					
	AX						
	AY						
	AZ						
Examiner 				Date Considered 12/01/04			

***Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.**